



Hiroaki YANAGITA, et al. Q96380
Filed: August 7, 2006 Art/Unit: Not Yet Assigned
Serial No. 10/588,659 Confirmation No. 9256
For: SEMICONDUCTOR MATERIAL AND
SEMICONDUCTOR DEVICE USING THE SAME
Replacement Sheet

FIG. 1

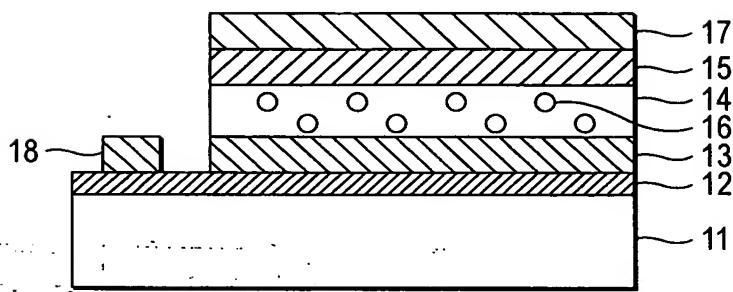


FIG. 2 (a)



FIG. 2 (b)

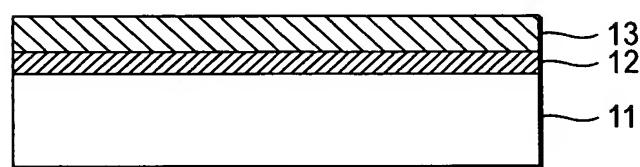


FIG. 2 (c)

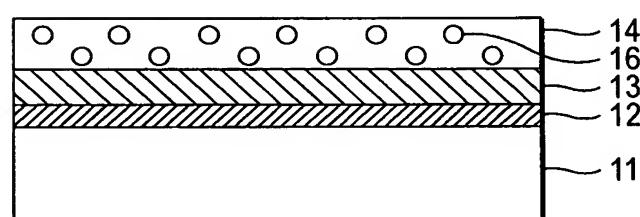


FIG. 2 (d)

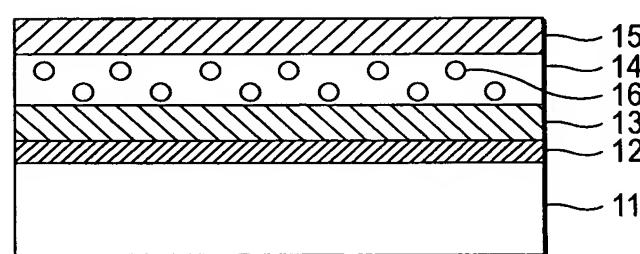
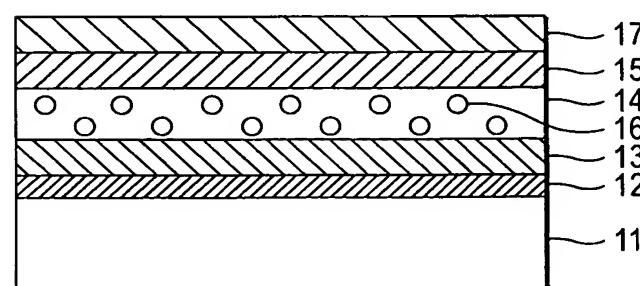
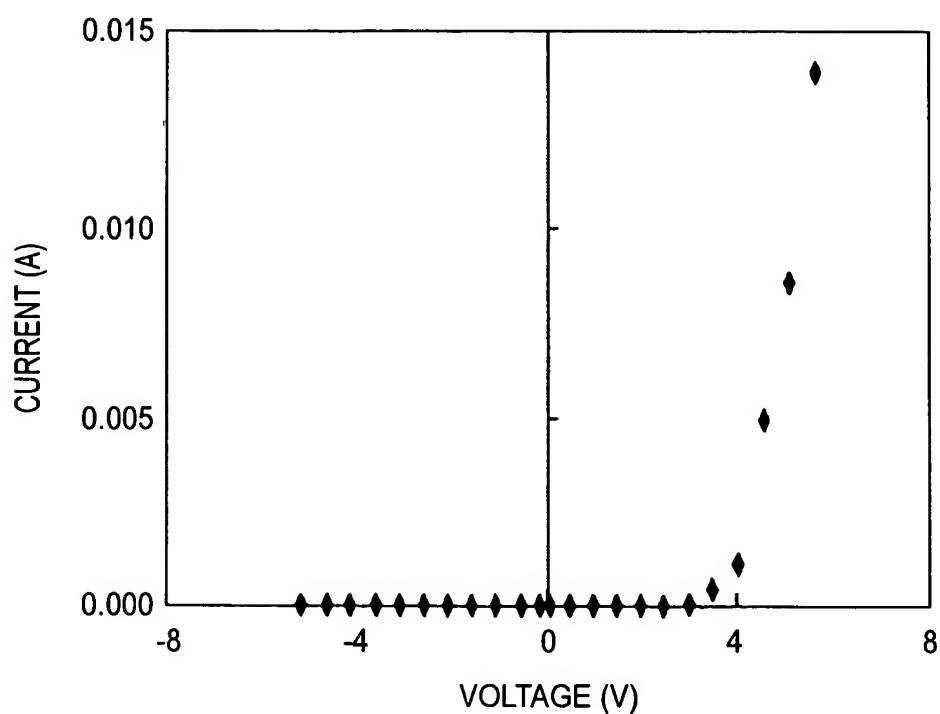


FIG. 2 (e)



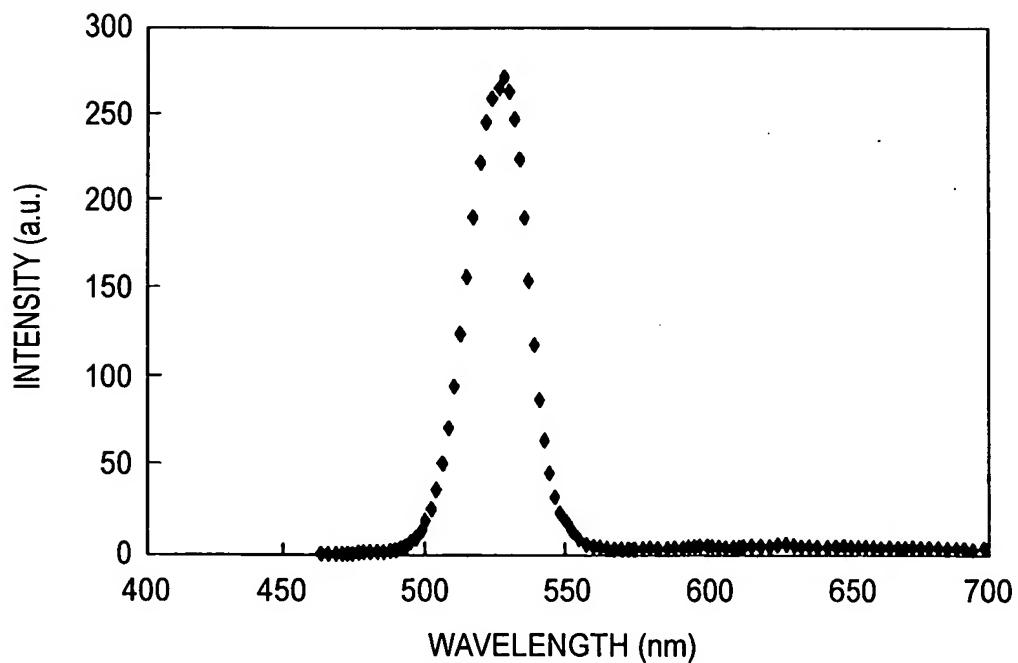
Hiroaki YANAGITA, et al. Q96380
Filed: August 7, 2006 Art/Unit: Not Yet Assigned
Serial No. 10/588,659 Confirmation No. 9256
For: SEMICONDUCTOR MATERIAL AND
SEMICONDUCTOR DEVICE USING THE SAME
Replacement Sheet

FIG. 3



Hiroaki YANAGITA, et al. Q96380
Filed: August 7, 2006 Art/Unit: Not Yet Assigned
Serial No. 10/588,659 Confirmation No. 9256
For: SEMICONDUCTOR MATERIAL AND
SEMICONDUCTOR DEVICE USING THE SAME
Replacement Sheet

FIG. 4



Hiroaki YANAGITA, et al. Q96380
Filed: August 7, 2006 Art/Unit: Not Yet Assigned
Serial No. 10/588,659 Confirmation No. 9256
For: SEMICONDUCTOR MATERIAL AND
SEMICONDUCTOR DEVICE USING THE SAME
Replacement Sheet

FIG. 5

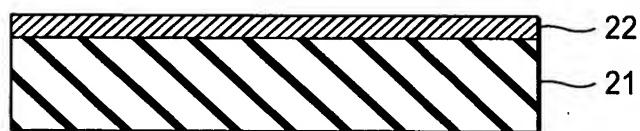
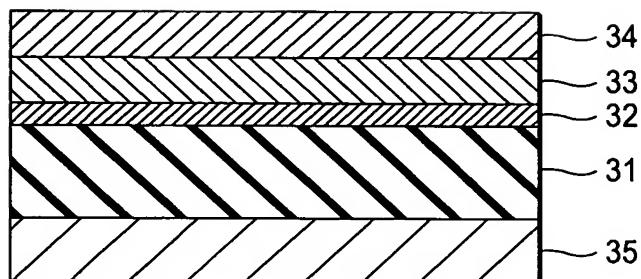


FIG. 6



Hiroaki YANAGITA, et al. Q96380
Filed: August 7, 2006 Art/Unit: Not Yet Assigned
Serial No. 10/588,659 Confirmation No. 9256
For: SEMICONDUCTOR MATERIAL AND
SEMICONDUCTOR DEVICE USING THE SAME
Replacement Sheet

FIG. 7

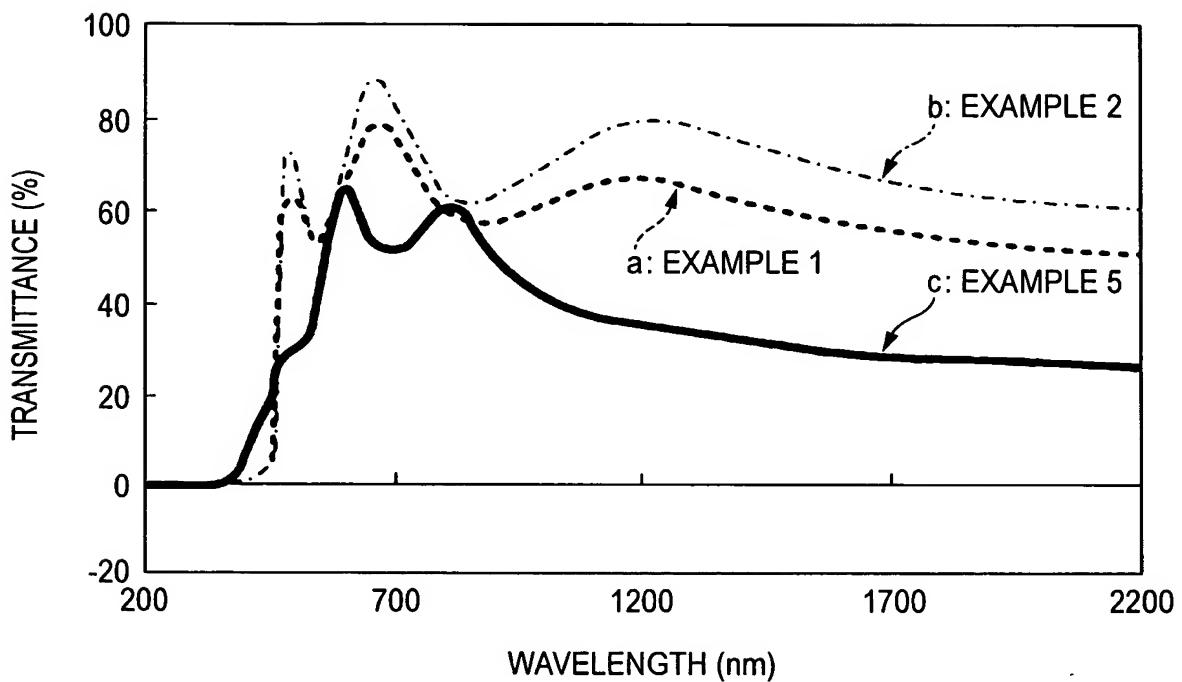


FIG. 8

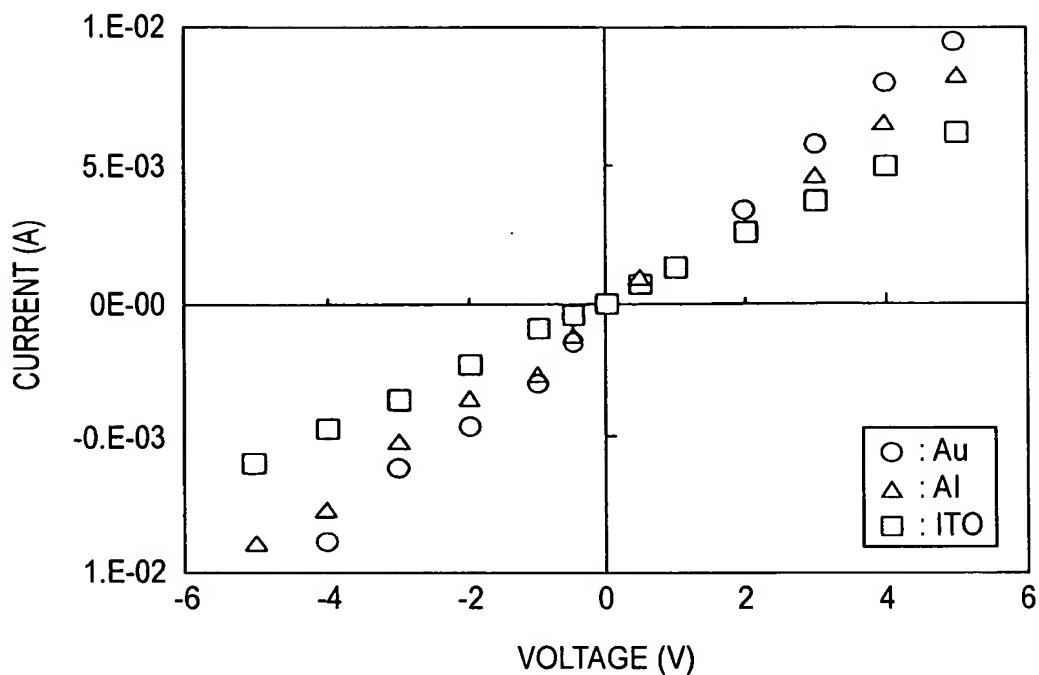
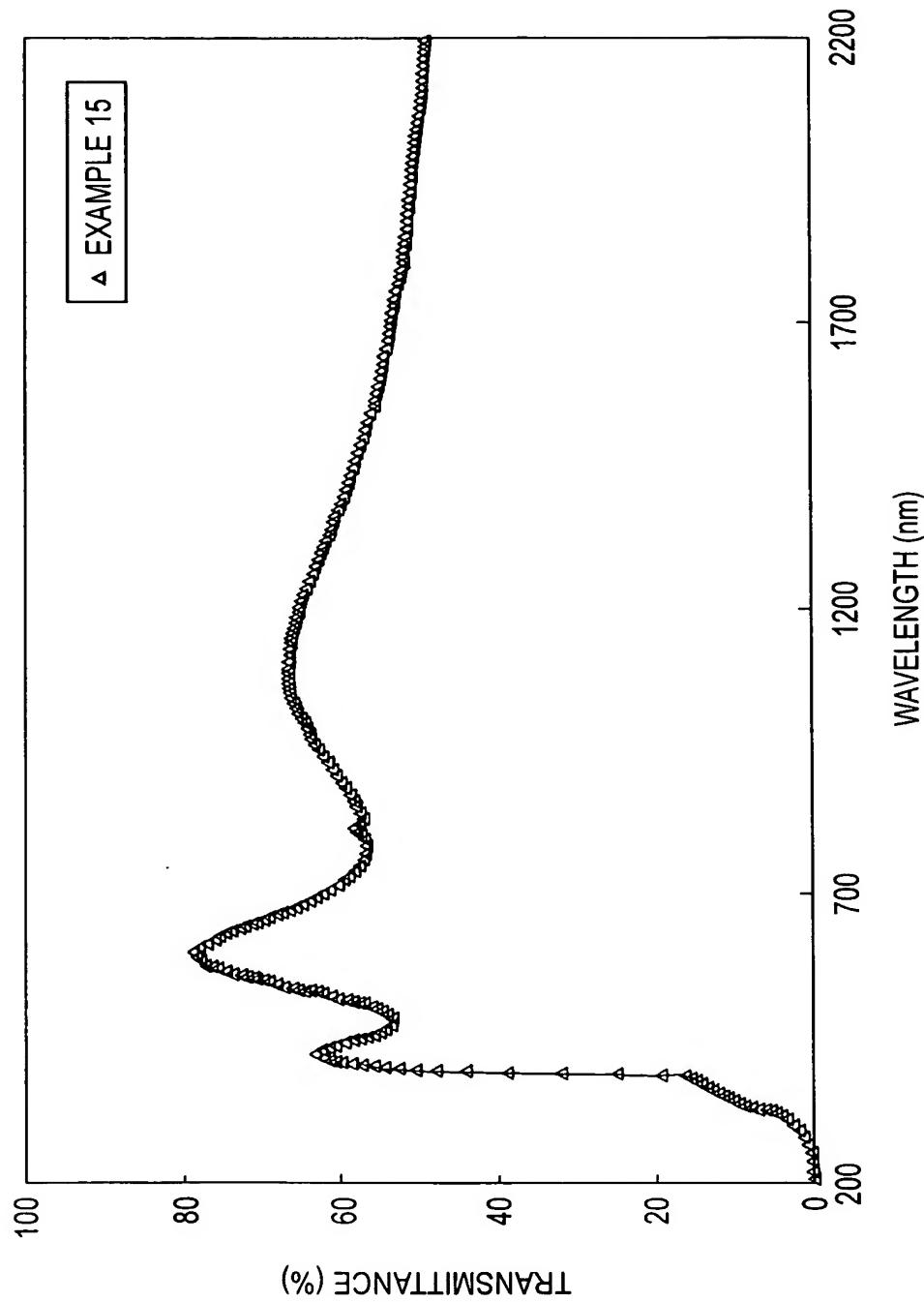
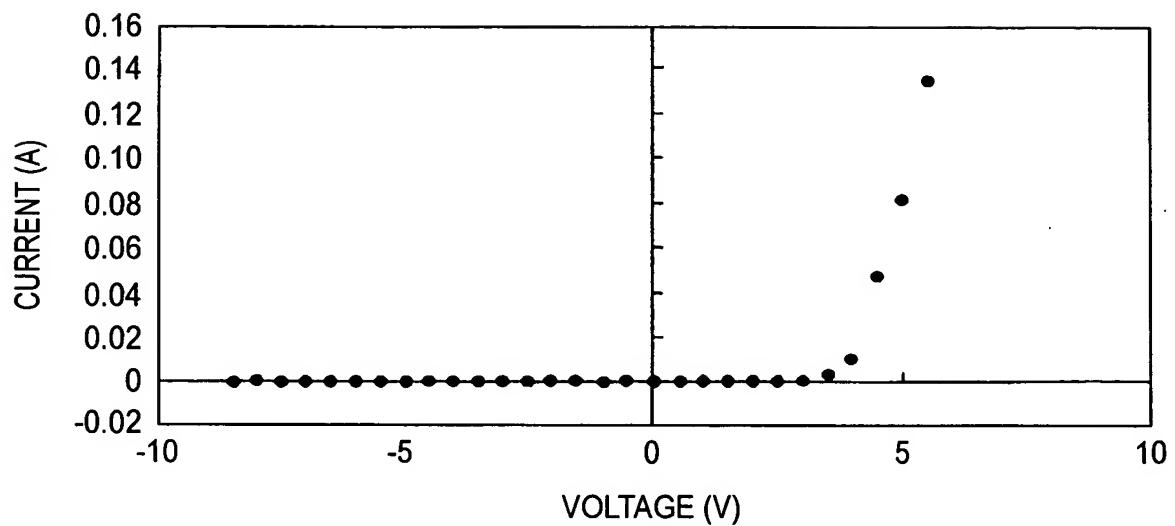


FIG. 9



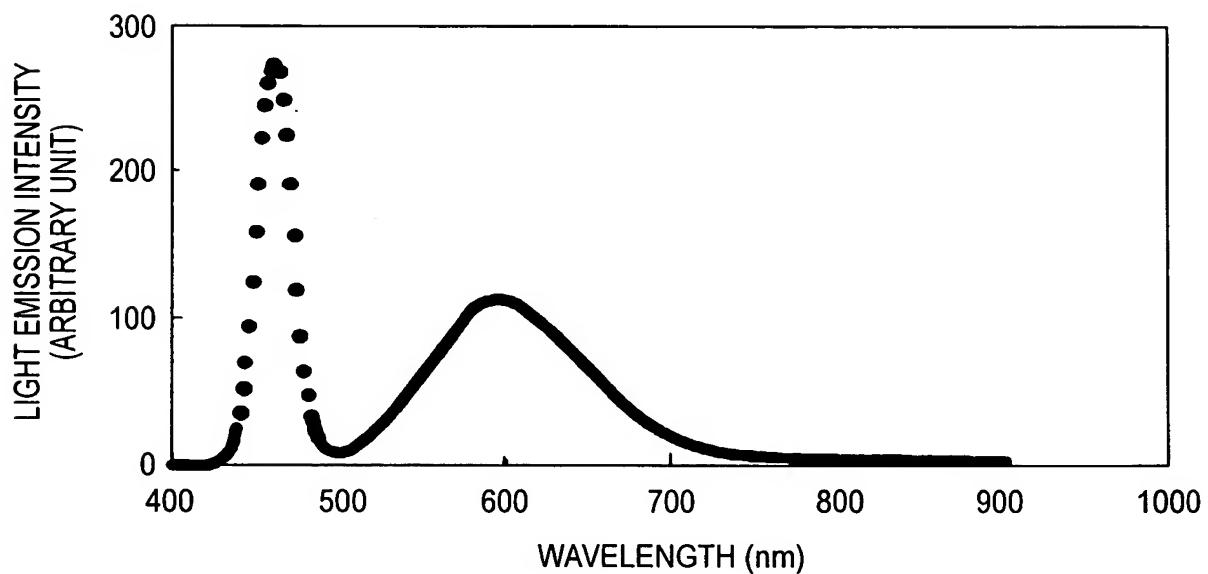
Hiroaki YANAGITA, et al. Q96380
Filed: August 7, 2006 Art/Unit: Not Yet Assigned
Serial No. 10/588,659 Confirmation No. 9256
For: SEMICONDUCTOR MATERIAL AND
SEMICONDUCTOR DEVICE USING THE SAME
Replacement Sheet

FIG. 10



Hiroaki YANAGITA, et al. Q96380
Filed: August 7, 2006 Art/Unit: Not Yet Assigned
Serial No. 10/588,659 Confirmation No. 9256
For: SEMICONDUCTOR MATERIAL AND
SEMICONDUCTOR DEVICE USING THE SAME
Replacement Sheet

FIG. 11



Hiroaki YANAGITA, et al. Q96380
Filed: August 7, 2006 Art/Unit: Not Yet Assigned
Serial No. 10/588,659 Confirmation No. 9256
For: SEMICONDUCTOR MATERIAL AND
SEMICONDUCTOR DEVICE USING THE SAME
Replacement Sheet

FIG. 12

